

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akihisa HONGO et al.

Serial No. 10/735,771

Filed December 16, 2003



: Confirmation No. 4044
: Attorney Docket No. 2003_1822A
: Group Art Unit 1792
: Examiner Sylvia R. MacArthur

SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Mail Stop: AMENDMENT

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of January 11, 2008.

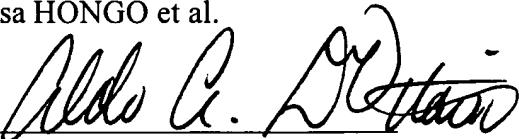
The fee of \$120.00 is

submitted herewith.

to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

Respectfully submitted,

Akihisa HONGO et al.

By 
Aldo A. D'Ottavio
Registration No. 59,559
Agent for Applicants

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April 30, 2008